

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Otto Z. ZHOU et al.

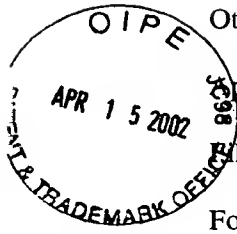
Application No.: 09/996,695

Filed: November 30, 2001

For: DEPOSITION METHOD FOR
NANOSTRUCTURE MATERIALS

Group Art Unit: ~~1743~~ **1741**

Examiner: ~~Unassigned~~ **Hicks**



INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

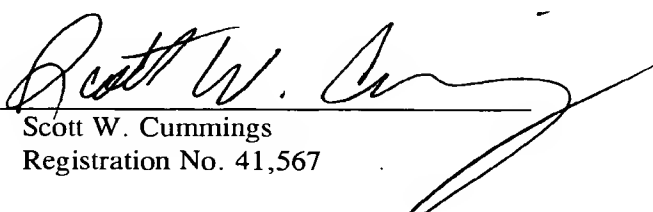
The documents are being submitted within 3 months of the filing or entry of the national stage of this application or before the first Office Action on the merits, whichever is later, therefore no fee or statement is required under 37 C.F.R. § 1.97(b).

The Examiner's attention is directed to the copending applications listed on the attached PTO-1449 form, a copy of which is furnished herewith pursuant to 37 C.F.R. § 1.98(a)(2). **By citation to the copending applications, confidentiality is not waived and the Office is requested to maintain the confidentiality of the copending applications under 25 U.S.C. § 122.**

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

By: 
Scott W. Cummings
Registration No. 41,567

P.O. Box 1404
Alexandria, Virginia 22313-1404
(703) 836-6620

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